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APPLICANTS

Bong Cheon Kim, Chungcheongbuk-do, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** none

** FOREIGN APPLICATIONS ***** SDF
 REPUBLIC OF KOREA 2002-67024 10/31/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 10/09/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no Met after Allowance <u>Examiner's Signature</u> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 1
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TITLE
 Method for forming isolation film in silicon substrate

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